Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
10/749,596	KIM ET AL.
Examiner	Art Unit
Donghee Kang	2811

SEARCHED				
Class	Subclass	Date	Examiner	
257	43,192,28 9,310,382- 384,410- 414	3/8/2005	KANG	
438	85,86,104	3/8/2005	KANG	
257	38-39,310	3/9/2005	KANG	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	43,192	3/9/2005	KANG
257	289,310	3/9/2005	KANG
257	410	3/9/2005	KANG
438/85-86,104		3/9/2005	KANG

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
east uspto,uspgpub,epo,jpo,dew,ibmtdb	3/8/2005	KANG
npl appy.phys.lett. j. of apply. phys leee exploer	3/8/2005	KANG
npl updated above	3/9/2005	KANG